

Interference Search

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	8	((mask or reticle) near4 (transmit\$5 and reflect\$3)) and (substrate or wafer or member) and (project\$3 or optical or lens) and (pattern or image or circuit) and (illumination or radiation or light) and (scan\$4 or orthogonal or perpendicular)).clm.	US-PGPUB	OR	ON	2005/12/22 16:46

7/c
12/22/05

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	11024	(mask or reticle) near3 reflect\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:52
L2	19258	(mask or reticle) near3 (transmit\$5 or transparen\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:53
L3	221736	(mask or reticle) same (substrate or wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:53
L4	971	1 same 2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:53
L5	661	4 and 3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:53
L6	135675	(pattern or image or circuit) near3 (mask or reticle)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:54
L7	596	5 and 6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:54
L8	117499	(pattern or image or circuit) near3 (contin\$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:54

L9	236481	(pattern or image or circuit) near3 (discontin\$5 or separat\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:55
L10	8	7 and 8 and 9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/22 16:55

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